

Kokusai Quixace Ultimate Vertical Low Pressure Chemical Vapor Deposition (LPCVD), 12"

Asset ID: 45995

Configuration Details:

Kokusai Quixace Ultimate Vertical Low Pressure Chemical Vapor Deposition (LPCVD), 12"

- MT-TiN
- Cartridge Heater - D4EX22250, RHC2 Heater
- Number of control zone, 5 zones
- Heater element material - KANTHAL APM
- Maximum heating temperature range - 1050 degC (in Furnace)
- Flat zone length - 800mm (± 2.0 degC at 800 degC)
- Main Controller(OU) - D4EX38403(KDSC-2007CONT), Made by HKDE
- Core2Duo 2.16GHz, 2.0GB, 80GB (RAID1), 100BASE-TX 3Ch, USB2.0
- Main Operation Unit - TM150-HKT05
- Sub Operation Unit - D4EX40577
- Bottle Heater (For Ta Source) - E-0456-17, Tokyo Gikken
- Bottle Heater (For Ta Source) - E-0456-17, Made by Tokyo Gikken
- Bubbling UNIT (For Ti Source) - D4EX31240, Made by Schumacher
- Bottle (For Ti Source) - BK1200URK, Made by Schumacher
- N2 Purge Load Lock System
- O2 Monitor / Detector - SH-305(RX-501052), Made by ENEGY SUPPORT
- FOUP Opener N2 Purge SYSTEM - Made by HITACHI KOKUSAI
- Pumps Included

2013 Vintage

Photos on Following Pages

To our knowledge, the information contained in this data sheet is accurate, but it may contain errors and we do not warrant the completeness or accuracy of this data.

Interested parties may contact Bridge Tronic Global for additional information at +1 949.396.1395 or sales@bridgetronic.com

Visit our website at: www.bridgetronic.com



QUICK
LEAD TIMES



QUALITY
EQUIPMENT



COMPETITIVE
PRICING



Interested parties may contact Bridge Tronic Global for additional information at +1 949.396.1395 or sales@bridgetronic.com



QUICK
LEAD TIMES



QUALITY
EQUIPMENT



COMPETITIVE
PRICING

